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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Akira HAMAMATSU et al.
Serial No.: 10/722,531
Filed: November 28, 2003
Title: INSPECTION METHOD AND INSPECTION APPARATUS
Group: 2877
Examiner: **STAFIRA**, Michael Patrick
Confirmation No.: 7610

AMENDMENT

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

December 9, 2005

Sir:

In response to the Office Action dated September 16, 2005, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the claims begin on page 2;

Remarks are included beginning on page 7; and

Authorization is included on page 11.